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JG
866

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10051299	FILING DATE 01/22/2002	CLASS 385	SUBCLASS 37	GAU 2874	EXAMINER Tina Lin
**APPLICANTS: Ohmura Masaki; Shigehara Masakazu;					
**CONTINUING DATA VERIFIED: THIS APPLN CLAIMS BENEFIT OF 60/340,484 12/18/2001					
** FOREIGN APPLICATIONS VERIFIED: JAPAN P2001-209826 07/10/2001 JAPAN P2002-012017 01/21/2002					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 50212-338	
Verified and Acknowledged Examiners's initials					
TITLE : Optical waveguide type defraction grating device and a method of manufacturing thereof <small>U.S. DEPT. OF COMM./PAT & TM-PTO-436L (Rev. 12-94)</small>					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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